

FORM PTO-1449	SERIAL NO. 10/530,634 <del>Not yet assigned</del>	CASE NO. 10808/231
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT  (use several sheets if necessary)	FILING DATE	GROUP ART UNIT
	Herewith	2826 <del>N/A</del>
APPLICANT(S): Jürgen HOLZ ET AL.		

**REFERENCE DESIGNATION U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER <small>Number-Kind Code (if known)</small>	DATE	NAME	CLASS/ SUBCLASS	FILING DATE
LC ↓ ↓ ↓ ↓ ↓ ↓ ↓ ↓	A1	US 2002/0142552 A1	October 3, 2002	Wu	
	A2	6,403,482	June 11, 2002	Rovedo et al.	
	A3	6,346,729 B1	February 12, 2002	Liang et al.	
	A4	US 2001/0025998 A1	October 4, 2001	Tsuchiaki	
	A5	US 2001/0017387 A1	August 30, 2001	Hsich et al.	
	A6	5,949,116	September 7, 1999	Wen	
	A7	5,908,313	June 1, 1999	Chau et al.	
	A8	5,620,912	April 15, 1997	Hwang et al.	
	A9	5,043,778	August 27, 1991	Teng et al.	

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER <small>Number-Kind Code (if known)</small>	DATE	COUNTRY	CLASS/ SUBCLASS	TRANSLATION YES OR NO
LC ↓ ↓	A10	WO 02/43109 A2	March 30, 2002	WO	
	A11	WO 01/50535 A2	July 12, 2001	WO	
	A12	DE 198 12 643 C1	July 8, 1999	Germany	
	A13	DE 197 49 378 A1	May 20, 1999	Germany	

**OTHER ART - NON PATENT LITERATURE DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	(Include name of author, title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date page(s), volume-issue number(s), publisher, city and/or country where published.
LC ↓ ↓ ↓	A14	Norbert Elbel, Zvonimir Gabric, Wolfram Langheinrich and Bernard Neureither, <i>A New STI Process Based on Selective Oxide Deposition</i> , pgs. 208-209, Symposium on VLSI Technology Digest of Technical Papers, IEEE, 1998.
	A15	N.G. Anantha, C.T. Horng, R.R. Konian and R.E. Matick, <i>Self-Aligned Igfet With Silicon Dioxide Isolated Source and Drain</i> , pgs. 4895-4899, IBM Technical Disclosure Bulletin, Vol 22, No. 11, April 1980.
	A16	Copy of International Search Report from corresponding PCT patent application no. PCT/DE03/03130. 2/3/2004
	A17	Copy of Examination Report from corresponding PCT patent application no. PCT/DE03/03130. 12/16/2004

EXAMINER /Leslie Cruz/	DATE CONSIDERED 12/28/2006
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.